

## PATENT ASSIGNMENT

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SUBMISSION TYPE:	NEW ASSIGNMENT												
NATURE OF CONVEYANCE:	EXECUTIVE ORDER 9424, CONFIRMATORY LICENSE												
CONVEYING PARTY DATA													
<table border="1"> <thead> <tr> <th>Name</th> <th>Execution Date</th> </tr> </thead> <tbody> <tr> <td>Massachusetts Institute of Technology</td> <td>03/01/2012</td> </tr> </tbody> </table>		Name	Execution Date	Massachusetts Institute of Technology	03/01/2012								
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RECEIVING PARTY DATA													
<table border="1"> <tr> <td>Name:</td> <td>National Science Foundation</td> </tr> <tr> <td>Street Address:</td> <td>4201 Wilson Blvd</td> </tr> <tr> <td>Internal Address:</td> <td>Room 1265</td> </tr> <tr> <td>City:</td> <td>Arlington</td> </tr> <tr> <td>State/Country:</td> <td>VIRGINIA</td> </tr> <tr> <td>Postal Code:</td> <td>22230</td> </tr> </table>		Name:	National Science Foundation	Street Address:	4201 Wilson Blvd	Internal Address:	Room 1265	City:	Arlington	State/Country:	VIRGINIA	Postal Code:	22230
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Invention Title: Position Controlled Deposition of Metal Nanoparticles

Inventor(s): Chun-Hao Tseng, Sung Keun Lim, Silviya Gradecak

U.S. Filing/Issue Date: 7/29/2009

Patent or Application Serial No.: 12/511634

Grant/Contract Number(s): DMR0745555

Foreign Applications filed/intended in (countries): \_\_\_\_\_

The invention identified above is a Subject Invention under **35 U.S.C. 200, et seq.**, and the Standard Patent Rights clause at **37 CFR 401.14, FAR 52.227-11** or **FAR 52.227-12** (if applicable) which are included among the terms of the above identified grant or contract award from the United State Government. This document is confirmatory of:

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Signed this 15<sup>th</sup> day of March, 20 12.

By \_\_\_\_\_ (Institutional Business Official) Rolande Johndro (Signature)

Title \_\_\_\_\_

For MASSACHUSETTS INSTITUTE OF TECHNOLOGY  
(Grantee/Contractor Organization)

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